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aperwork Reduction Act of 1995, no pe	rsons are required to respond to a collecti Application Number	on of information unless it displays a valid OMB control number.								
TRANSMITTAL		10/642,439								
FORM	Filing Date	14 Aug 2003								
FORIVI	First Named Inventor	Brophy								
(to be used for all correspondence after initial filing)	Art Unit	1755								
	Examiner Name	James W. Pasterczyk								
Total Number of Pages in This Submission 29	Attorney Docket Number	02-024								
ENCLOSURES (Check all that apply) After Allowance communication										
Fee Transmittal Form Fee Attached Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s)	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Addi Terminal Disclaimer Request for Refund CD, Number of CD(s)	to Technology Center (TC) Appeal Communication to Board of Appeals and Interferences Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter ✓ Other Enclosure(s) (please Identify below): Form 1449 w/ref								
Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53	E OF APPLICANT, ATTORN	EY, OR AGENT								
Firm Frank Rosenberg	· · · · · · · · · · · · · · · · · · ·									
or Individual name										
Signature (
Date 1 August 2006										
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		r deposited with the United States Postal Service with tents, P.O. Box 1450, Alexandria, VA 22313-1450 on								
Typed or printed name Esmeralda Mestizo										
Signature EMESTI	30	Date 1 August 2006								
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This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Brophy et al.

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Application No. 10/642,439

Art Unit: 1755

Filed: Aug 14, 2003

Examiner: James W. Pasterczyk

E. TETHEDED CA

: Atty Docket: 02-024

For: TETHERED CATALYST

PROCESS IN MICROCHANNEL
REACTORS AND SYSTEMS
CONTAINING A TETHERED
CATALYST OR TETHERED

CHIRAL AUXILIARY

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 CFR §§ 1.56 and 1.97-1.99, the documents listed on the attached Form(s) PTO-1449 are being brought to the attention of the Examiner in charge of the above-identified application. Because no first Office Action on the merits has been mailed, it is believed that no fees are due; however, if any fees are required for consideration of this Information Disclosure Statement, please charge such fees to Deposit Account No. 50-1749.

The Examiner is respectfully requested to initial the space adjacent each document entry on the Form(s) PTO-1449, and to return a copy of the initialled Form(s) PTO-1449 to confirm that the documents have been considered and have been officially made of record in this application.

If the Examiner has any questions or wishes to discuss this application, the Examiner is invited to telephone the undersigned representative at the number set forth below.

Respectfully submitted,

Date: 1 Au, 2006

Frank Rosenberg

Registration No. 37,068 Tel. No. 925-376-8429

Page 1 of 1

Form PTO-1449 AUG: 6'3, 2006 Information Disclosure Citation				Attorney Docket Application No. 10/642,439 Applicant Brophy et al.						
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		Other Docu	ments (Including	Author, Ti	tle, Date, Pertinent Pa	ages, etc.)				
		Haswell et al., "Kumada-Corriu reactions in a pressure-driven microflow reactor," Lab on a Chip, 1, 164-166 (Aug 2001).								
		Pennemann et al., "Benchmarking of Microreactor Applications," Organic Process Res. Dev., 8, 422-439 (2004).								
		Watts et al., "The application of micro reactors for organic synthesis," Chem. Soc. Rev., 34, 235-246 (Feb 2004).								
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		Wiles et al., "An investigation into the use of silica-supported bases within EOF-based flow reactors," Tetrahedron, 60, 8421-8427 (2004).								
Examiner					Date Considered					
EXAMINER: Ir conformance a	itial if re	eference considered, whethered copy of the	ther or not citation is in of this form with next of	n conformant	ce with MPEP § 609. Dragon to Applicant.	w line throug	jh citation if r	not in		